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APPLICANTS

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** CONTINUING DATA *****

This application is a 371 of PCT/JP05/01513 02/02/2005

** FOREIGN APPLICATIONS *****

JAPAN 2004-032607 02/09/2004

** IF REQUIRED, FOREIGN FILING LICENSE GRANTED *** SMALL ENTITY **

04/09/2007

Foreign Priority claimed	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	35 USC 119(a-d) conditions met	<input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	STATE OR COUNTRY	SHEETS DRAWINGS	TOTAL CLAIMS	INDEPENDENT CLAIMS
Verified and /CARIDAD EVERHART/ Examiner's Signature	<input type="checkbox"/> Met after Allowance		Initials	JAPAN	6	25	3
Acknowledged							

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TITLE

Method of manufacturing a semiconductor device and method of etching an insulating film

FILING FEE RECEIVED 575	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees
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